Search Notes					

Application No.	Applicant(s)
10/611,862	IWASAKI ET AL.
Examiner	Art Unit
Stephen W. Smoot	2813

SEARCHED				
Class	Subclass	Date	Examiner	
257	412	3/4/2004	sws	
257	413	3/4/2004	sws	
257	762	3/4/2004	sws	
257	766	3/4/2004	sws	
257	768	3/4/2004	sws	
257	769	3/4/2004	sws	
257	774	3/4/2004	sws	
438	620	3/4/2004	sws	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
		•			
4					

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Considered All Citations and Search Reports from Parent Applications.	3/4/2004	S.W.S. sws		
Key Words: Copper Interconnect - Multilayer Film - Layer of Platinum, Iridium, Osmium, Rhodium, Ruthenium;	3/4/2004	J.W.J. sws		
Plus Additive of Cobalt, Nickel, Palladium, Titanium;	3/4/2004	S.V.S sws		
Contact to Source/drain or Gate; Gate Electrode Including Layer of Platinum, Iridium, Osmium, Rhodium, Ruthenium	3/4/2004	L. W. S.		
Search Tools - EAST (attached): USPAT; US PG PUBS; Derwent; EPO; JPO; IBM TDB	3/4/2004	8.W.8 sws		